



SEPP21001C1

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Tois et al.
Appl. No. : 10/678,766
Filed : October 2, 2003
For : METHOD OF GROWING OXIDE
THIN FILMS
Examiner : Unknown

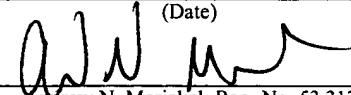
Group Art Unit : 1765

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

January 27, 2004

(Date)


Andrew N. Merickel, Reg. No. 53,317

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Applicants request entry of the following amendments to the specification of the present application.

Amendments to the Specification begin on page 2 of this paper.

Remarks/Arguments begin on page 3 of this paper.